

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Uwe SCHWARZ

Serial No: 10/537,211

Examiner: Reema Patel

Filed: March 20, 2006

Group Art Unit: 2812

For: PRODUCTION OF MICROELECTROMECHANICAL SYSTEMS (MEMS) USING
THE HIGH TEMPERATURE SILICON FUSION BONDING OF WAFERS

Confirmation: 1865

PETITION FOR EXTENSION OF TIME, 37 C.F.R. §1.136(a)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicant request retroactive extension of the term for response to the official action mailed May 15, 2007, to and including the filing of the accompanying amendment under 37 C.F.R. §1.111. The required official fee for a two month extension is submitted by EFS charge authorization. Please charge any underpayment or credit any overpayment to Deposit Account 04-1679.

Date: October 12, 2007

Attorney Docket: D4695-00135
[11415us/Mj]

Respectfully submitted,

/Stephan Gribok/
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